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MS AF REPLY UNDER 37 C.F.R. § 1.116 EXPEDITED PROCEDURE **EXAMINING GROUP 2823**

PATENT 0941-0841P

IN THE U.S. PATENT AND TRADEMARK OFFICE

Applicant:

Ming-Tsong WANG et al. Conf.:

5290

Appl. No.: 10/660,573

Group:

2823

Filed:

September 12, 2003

Examiner: J.J. MOLDONADO

For:

PROCESS FOR FORMING METAL DAMASCENE

STRUCTURE TO PREVENT DIELECTRIC LAYER

PEELING

LARGE ENTITY TRANSMITTAL FORM

FOR REPLY AFTER FINAL UNDER 37 C.F.R. § 1.116

MS AF

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450 December 9, 2004

Sir:

Transmitted herewith is an amendment in the above-identified application.

The enclosed	document	is	being	trans	mitted	via	the	Certificate
of Mailing p	rovisions	of	37 C.	F.R.	§ 1.8.			

The enclosed document is being transmitted via facsimile.

The fee has been calculated as shown below:

	CLAIMS REMAINING AFTER AMENDMENT		HIGHEST NUMBER PREVIOUSLY PAID FOR		PRESENT EXTRA	RATE	ADDITIONAL FEE
TOTAL	24	-	40	=	0	\$50	\$0.00
INDEPENDENT 3		_	4	=	0	\$200	\$0.00
FIRST PRESENTATION OF A MULTIPLE DEPENDENT CLAIM \$360 \$0.							\$0.00
						TOTAL	\$0.00

		onth(s) extension of time pursuant to .136(a). \$0.00 for the extension of		
\boxtimes	No fee is required.			
	Check(s) in the amount o	f \$0.00 is(are) enclosed.		
	Please charge Deposit Ac \$0.00. This form is subm	ccount No. 02-2448 in the amount of itted in triplicate.		
If necessary, the Commissioner is hereby authorized in concurrent, and future replies, to charge payment or credit overpayment to Deposit Account No. 02-2448 for any additional required under 37 C.F.R. §§1.16 or 1.17; particularly, extensitime fees.				
	I	Respectfully submitted,		
	I	BIRCH, STEWART, KOLASCH & BIRCH, LLP		
	F	Joe McKinney Muncy, #32,334		
KM/RI		P.O. Box 747 Falls Church, VA 22040-0747		
		(703) 205-8000		
Attac	chment(s)			

DEC 0 9 2004 BERTARAN TRADEMARK

REPLY UNDER
37 C.F.R. § 1.116
EXPEDITED PROCEDURE
EXAMINING GROUP 2823

PATENT 0941-0841P

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Applicant: Ming-Tsong WANG et al. Conf.: 5290

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AMENDMENT AFTER FINAL UNDER 37 C.F.R. § 1.116

MS AF

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

December 9, 2004

Sir:

In reply to the Office Action dated October 5, 2004, the following amendments and remarks are respectfully submitted in connection with the above-identified application.

This reply includes: Amendments to the Claims and Remarks.